

Supplemental Document: New non-pyrophobic metalorganic precursor for ALD for Ga₂O₃

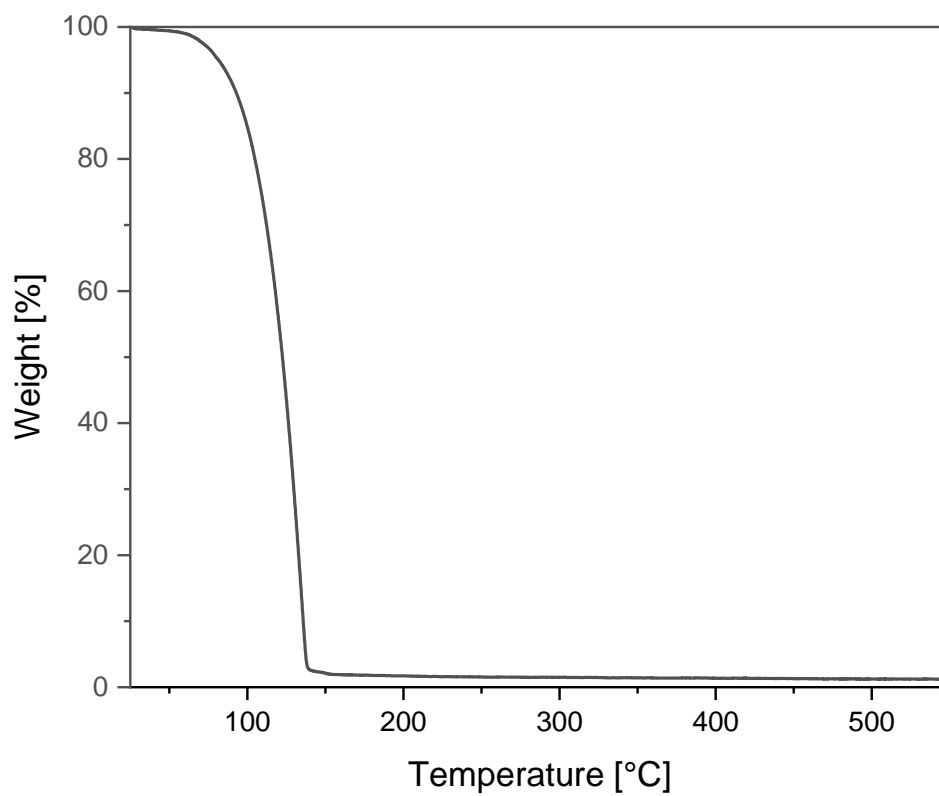


Figure 1: Thermogravimetric Analysis of the new precursor.